

Abstract of Disclosure

MULTI-CHAMBER CARRIER

A multi-chamber carrier is disclosed. The multi-chamber carrier includes an enclosure having a chamber therein and a first isolation plate and a second isolation plate separating the chamber of the enclosure into a first sub-chamber for trapping contaminant particles and a second sub-chamber for enclosing a plurality of wafers. The first isolation plate and the second isolation plate preferably include a plurality of slanted holes therein.

Figure 1